

Production of ^{226}Ra -implanted high-quality radon sources for detector characterization

72nd Meeting of the INTC - 2023

- **Florian Jörg**, Hardy Simgen, Christoph Schweiger, Klaus Blaum

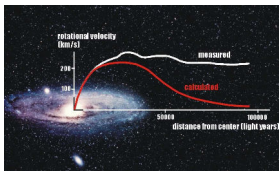
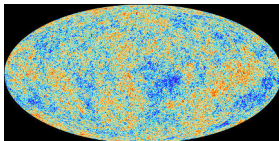
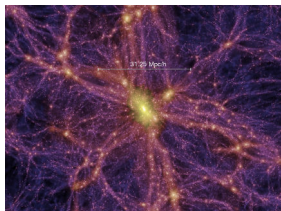
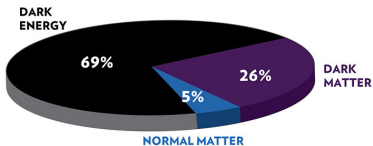


February 08, 2023

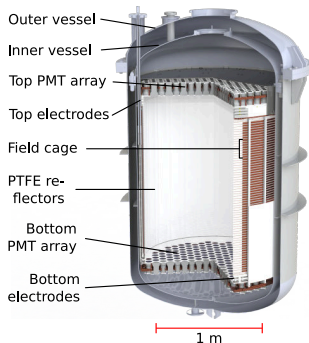
Why to search for (WIMP) dark matter

Many hints from Cosmology and Astronomy on its existence

Weakly interacting massive particles

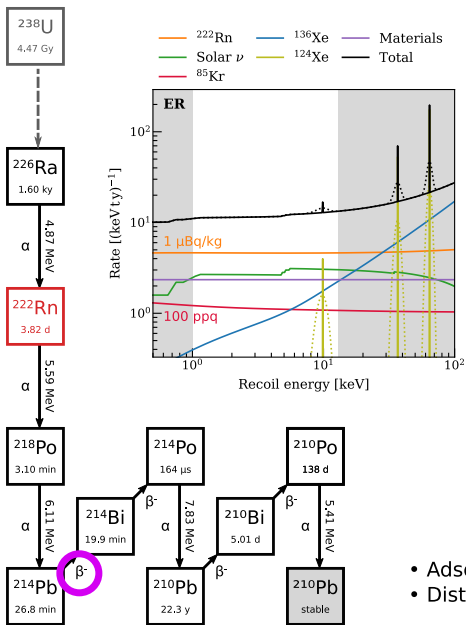


Direct search with liquid xenon detectors



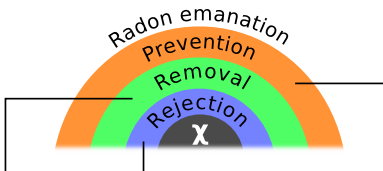
XENONnT Detector

Why do we care about radon?



JCAP11(2020)031 & arXiv: 2007.08796

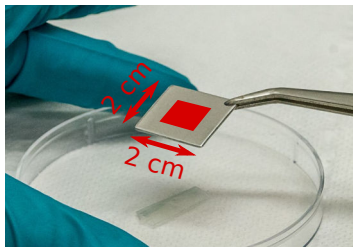
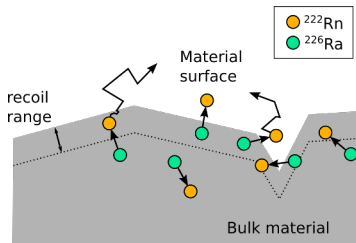
- ▶ ^{222}Rn emanates from materials and mixes with LXe
- ▶ Dominant background in rare event searches
- ▶ Radon **mitigation** → radon **detection** → radon **sources**
- ▶ Also relevant in other fields (radioprotection, environmental physics, ...)!



- Adsorption
- Distillation
- ER/NR separation
- ...
- **Screening**
- **Coating**
- ...

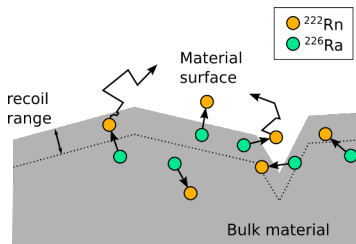
New type of radon source: Proof-of-principle study

- ▶ Two samples with 5×10^{11} ^{226}Ra ions (≈ 7 Bq) (2017)
- ▶ *Off-line* implantation using uranium carbide target (1.2×10^{18} POT)
- ▶ **General purpose separator**
- ▶ Ion beam (30 keV, 3pA), area of about $1 \times 1 \text{ cm}^2$



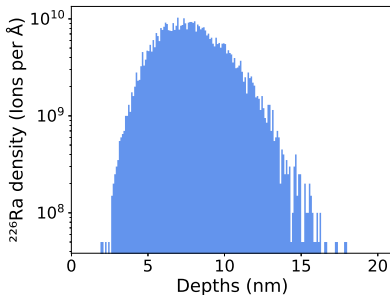
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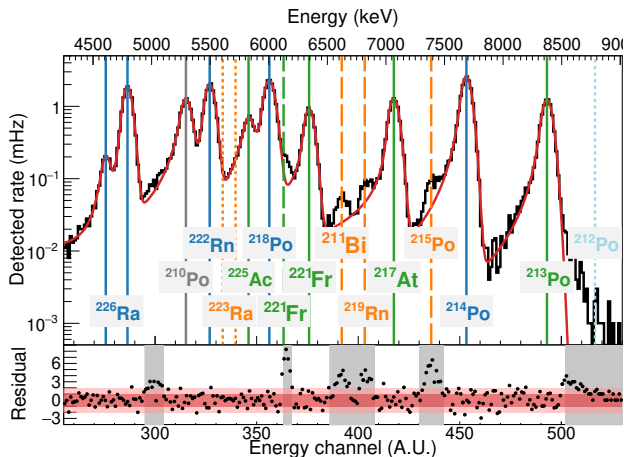


Simulated implantation profile

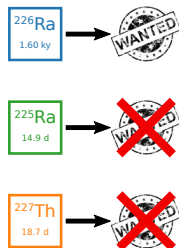
- ▶ Ion range distribution (SRIM)
 $\mu = 7.9 \text{ nm}$, $\sigma = 2.3 \text{ nm}$
- + High radon emanation fraction (expectation: 23%)
- + Mechanical stability assessed by wiping test: $< 1\%$ removal



Observation of short-lived contaminants



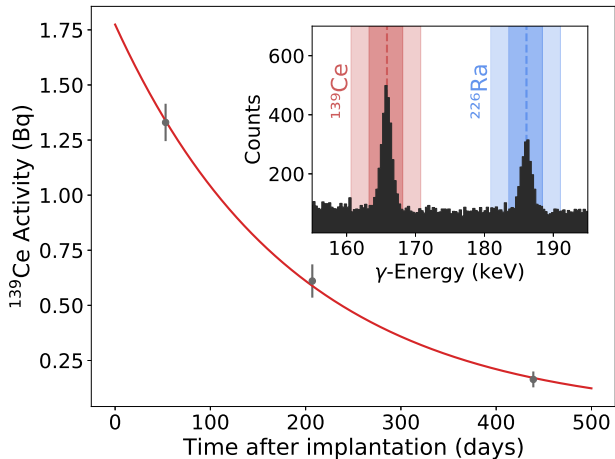
Contaminants



α -spectrum from 13 weeks after implantation:

- ▶ Unwanted isotopes decay with $\mathcal{O}(\text{weeks})$ of half-life
→ **no problem**

Unexpected ^{139}Ce contamination?

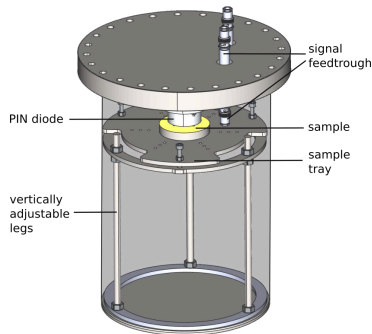
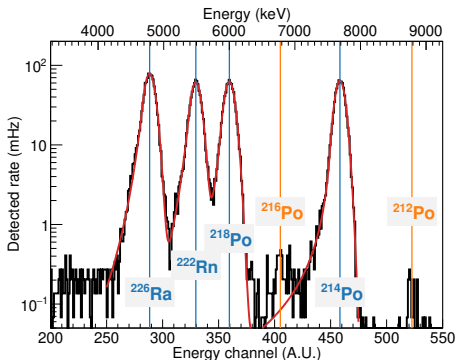
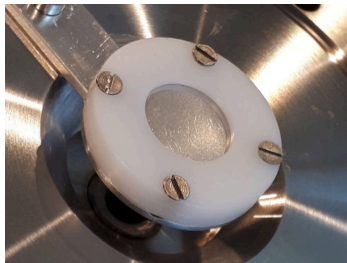


- ▶ Single γ -emission at 165.9 keV, matching ^{139}Ce
- ▶ Decay of this activity found with (130 ± 5) days, matching literature value of $T_{1/2}(^{139}\text{Ce}) = 137.6$ days
- ▶ Present only on Sample B

Alpha spectrometry (Si-PIN)

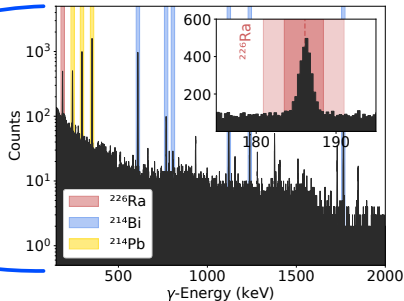
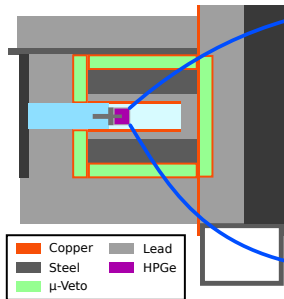
- ✓ Implantation confined within opening of holder (1.9 cm)

α -activity	^{226}Ra (4.9 MeV)
Sample A	(8.7 ± 1.9) Bq
Sample B	(9.1 ± 0.7) Bq



Gamma spectrometry (HPGe)

D. Budjaš PhD thesis (2009)



0.63 kg p-type HPGe crystal

- ▶ 15 mwe at MPIK, active & passive shielding

- ▶ N₂-flushed sample chamber
⇒ emanated ²²²Rn removed

Activity (Bq)	Sample A	Sample B
²²⁶ Ra (186 keV)	7.4 ± 0.9	8.4 ± 1.0
Rn-daughters	5.2 ± 0.3	6.0 ± 0.3



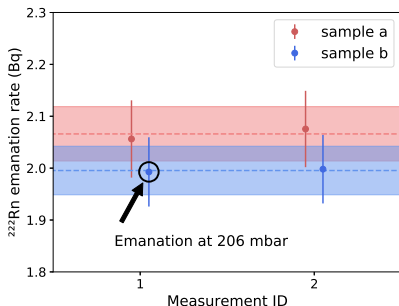
Emanation vessel

- ▶ Sample enclosed in vacuum tight stainless steel vessel
- ▶ Aluminum holder for fixation
- ▶ Vessel filled with helium (1050 mbar)

Results

- ▶ Measured using low-level, quartz proportional counters
- ▶ Very good agreement

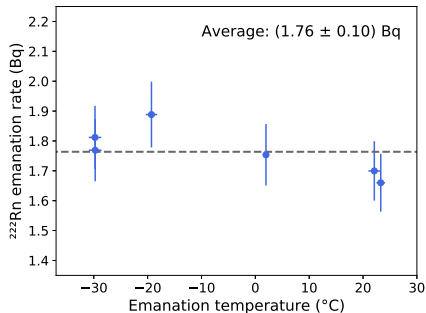
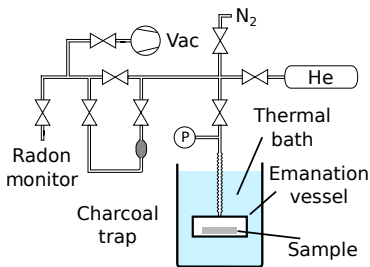
Sample	^{222}Rn emanation
Sample A	$(2.07 \pm 0.05) \text{ Bq}$
Sample B	$(2.00 \pm 0.05) \text{ Bq}$



Thermal dependence of radon emanation

Used setup

- ▶ Emanation vessel placed in thermal bath with 200 mbar Helium
- ▶ ^{222}Rn emanation is collected on active charcoal trap (LN₂ temperature)



Result

- ▶ ^{222}Rn is then filled into electrostatic radon monitor
- ▶ No temperature variation down to -30°C

Results from full characterization

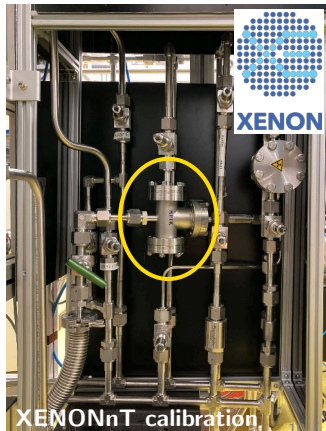
Activity (Bq)	Sample A	Sample B
Implantation	about 7	about 7
^{222}Rn emanation	$2.07 \pm 0.03_{\text{stat}} \pm 0.04_{\text{syst}}$	$2.00 \pm 0.03_{\text{stat}} \pm 0.04_{\text{syst}}$
γ -spectrometry	$7.4 \pm 0.1_{\text{stat}} \pm 0.9_{\text{syst}}$	$8.4 \pm 0.3_{\text{stat}} \pm 1.0_{\text{syst}}$
α -spectrometry	$8.70 \pm 0.06_{\text{stat}} \begin{matrix} +2.0 \\ -1.8 \end{matrix}_{\text{syst}}$	$9.13 \pm 0.10_{\text{stat}} \begin{matrix} +0.7 \\ -0.4 \end{matrix}_{\text{syst}}$

Appl. Radiat. Isot. 194 (2023) 110666 & arXiv: 2205.15926

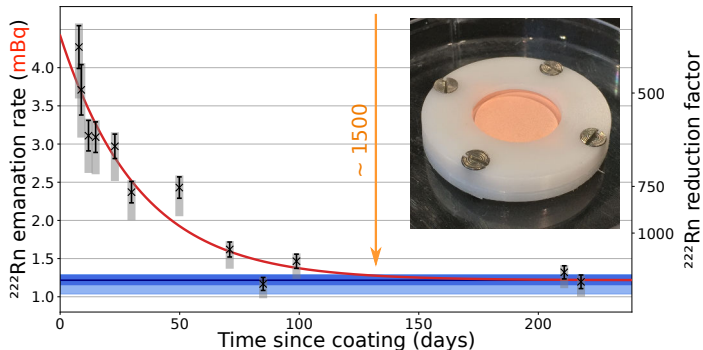
- ▶ Recoil dominated emanation of ^{222}Rn
→ Stable wrt. pressure, temperature, etc.
- ▶ Emanation from a bare stainless steel surface
→ Low outgassing of impurities

Applicability of implanted sources:

- ▶ Radon detectors and α -spectrometers
- ▶ Calibration of large scale LXe detectors!
- ▶ Radon mitigation studies (coating)



Results using ^{226}Ra implanted stainless steel samples



- ▶ ^{222}Rn reduction of ≈ 1500 using $5\ \mu\text{m}$ electroplated copper
- ▶ Coating becomes “tighter” \Rightarrow room temperature annealing?

Activity (Bq) γ -Spectrometry	Sample		Electrolyte
	^{226}Ra	Rn-daughters	Rn-daughters
before coating	8.4 ± 1.0	6.0 ± 0.3	$\lesssim 0.012$
after coating	7.7 ± 1.0	7.2 ± 0.4	0.34 ± 0.02

Proposal for ^{226}Ra implantation into further samples

- ▶ **Metals:** $\sim 10\times$ Stainless steel, $2\times$ Copper, $2\times$ Titanium

Materials commonly used in low-background experiments (i.e. cryostats)

- ▶ **Insulators:**

$2\times$ PTFE, $1\times$ Quarz

Light reflectors in LXe TPCs,

Proportional counters

Isotope	Target	Ion source	Beam current
^{226}Ra	UC_x	Surface	3 pA

- ▶ **Semiconductors:**

$1\times$ Si, $1\times$ Ge

Target materials for dark

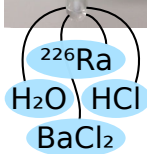
matter and $0\nu\beta\beta$ searches

Samples	N_{ions}	Shifts	Protons required
20	3×10^{11}	12	No

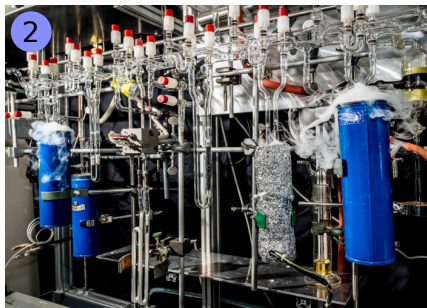
- ▶ Default material for coating studies: Stainless steel
- ▶ Emanation fraction from diffusion vs. recoil in each material?
- ▶ Influence of humidity and temperature?
- ▶ Dependence on the gas type (He, N_2 , Xe)?
- ▶ Emanation into vacuum vs. gas vs. liquid?

Backup slides

How to measure ^{222}Rn emanation (at MPIK)



1. Extraction of ^{222}Rn e.g. from ^{226}Ra solution
2. Transfer and purification of the sample
3. Counting (proportional counters, electrostatic radon monitors) MDA $\approx 30 \mu\text{Bq}$



- ▶ Need reliable ^{222}Rn sources
- ▶ Radon mitigation using surface coatings

Bonus: Comparison to the PTB sample

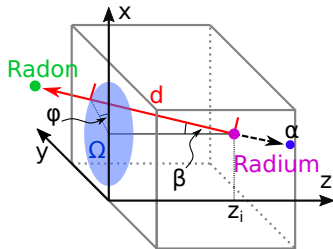
		MPIK	PTB
	Obtained samples	2×SS	4×Al + 4×W
Production	Implanted activity	about 7 Bq	0.5 kBq - 1 kBq
	Ion Energy	30 keV	30 keV
	²²⁶ Ra source	Produced in UC _x	²²⁶ Ra drop-cast on foil
	Ionization	Surface (3 pA)	Surface & Laser (10 nA)
Measurements	Emanation process	Recoil	Recoil
	Mechanical stab.	✓	✓
	Environment	cold, pressure	warm, humidity
	Reference	Appl. Radiat. Isot. 194 , 2023	Appl. Radiat. Isot. 181 , 2022

⇒ **Very promising source production process!**

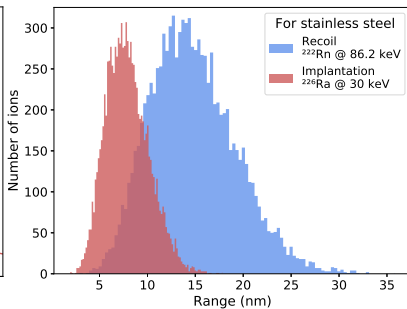
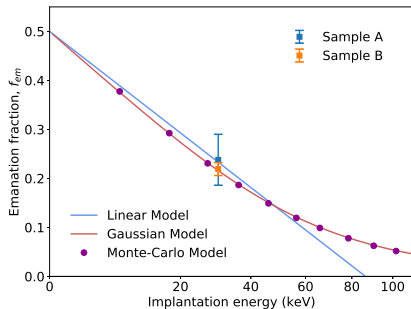
Models for recoil-driven emanation fraction

Linear model

$$\Omega = \int_0^{2\pi} \int_0^{\beta_{crit}} (\sin(\beta)) d\beta d\varphi$$
$$\Rightarrow F = \frac{1}{2} \cdot \left(1 - \frac{z_i}{R}\right), \text{ for } z_i \leq R$$



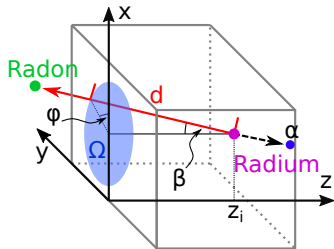
Gaussian and Monte-Carlo model



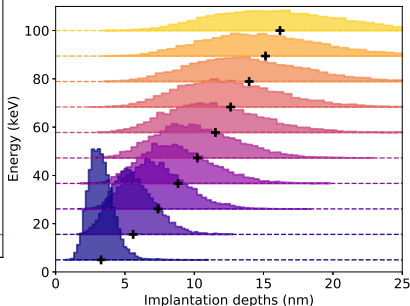
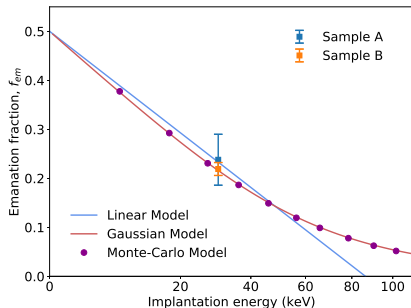
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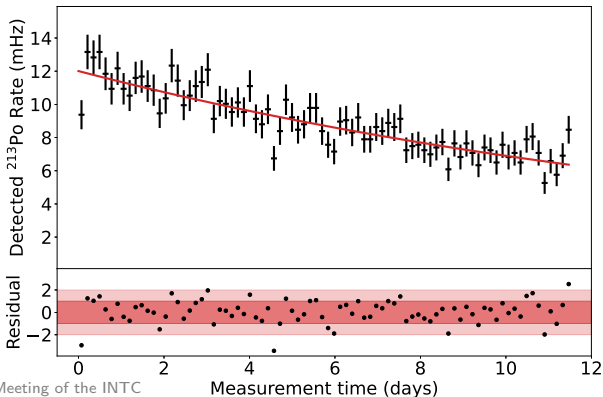
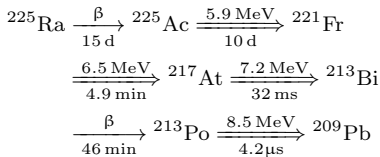


Gaussian and Monte-Carlo model



Short-lived isotopes details

Isotope	N_{ions}	Initial activity
^{226}Ra	10^{12}	$\mathcal{O}(10 \text{ Bq})$
^{225}Ac	10^9	$\mathcal{O}(1 \text{ kBq})$
^{227}Th	10^7	$\mathcal{O}(1 \text{ Bq})$
$^{228}(\text{Th/Ra})$	10^6	$\mathcal{O}(10 \text{ mBq})$



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